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Docket No.: 4006-275

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of :
Wen-Jian LIN : Confirmation No.7651
U.S. Patent Application No. 10/706,923 : Group Art Unit: 2873
Filed: November 14, 2003 : Examiner: JESSICA T. STULTZ
For: A METHOD FOR FABRICATING AN INTERFERENCE DISPLAY UNIT

RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

By Official Action mailed February 4, 2005 restriction to one of the following inventions is required under 35 USC 121:

- I. Claims, 1-8, drawn to an optical interference display comprising a first and second electrodes.
- II. Claims, 9-23, drawn to a method of manufacturing a color optical interference display unit comprising forming a first electrode and a sacrificial layer covered by additional electrode layers.

In response, Applicant hereby elects Claims 1-8 for examination in this case.

Applicant intends to file a divisional application for non-elected Claims 9-23.

Early examination on the merits is courteously solicited.

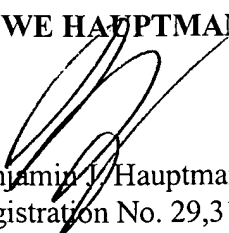
To the extent necessary, a petition for an extension of time under 37 C.F.R. 1.136 is hereby made. Please charge any shortage in fees due in connection with the filing of this paper, including

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extension of time fees, to Deposit Account 07-1337 and please credit any excess fees to such deposit account.

Respectfully submitted,

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